INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

March 23, 2026

IGI Report Number	LG783636225
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	11.55 X 7.75 X 5.11 MM

GRADING RESULTS

Carat Weight	4.02 CARATS
Color Grade	E
Clarity Grade	VS 2

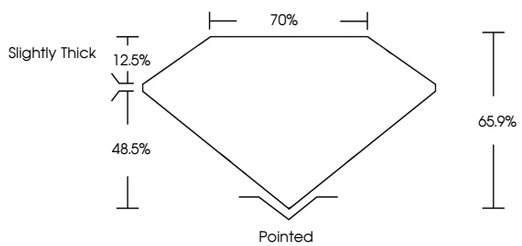
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG783636225

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG783636225
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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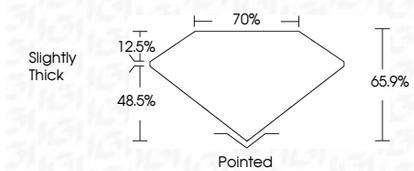

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IGI

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CUT CORNERED RECT. MODIFIED BRILLIANT
11.55 X 7.75 X 5.11 MM

Carat Weight	4.02 CARATS
Color Grade	E
Clarity Grade	VS 2
Depth	65.9%
Table	70%
Girdle	Slightly Thick
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG783636225

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